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PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

WGT

APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
10066835	02/04/2002	428	12	1775	10066835

**APPLICANTS: Lin Tsann; Mauri Daniele;

**CONTINUING DATA VERIFIED:
THIS APPLICATION IS A CIP OF 09/919,280 07/31/2001

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** FOREIGN APPLICATIONS VERIFIED:

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>	ATTORNEY DOCKET NO
Foreign priority claimed	<input type="checkbox"/> yes <input type="checkbox"/> no		
35 USC 119 conditions met	<input type="checkbox"/> yes <input type="checkbox"/> no		
Verified and Acknowledged Examiners's initials			SJO920010058US1
TITLE : In-situ oxidized films for use as gap layers for a spin-valve sensor and methods of manufacture			

U.S. DEPT. OF COMM./PAT. & TM.-PTO-436L (Rev. 12-94)

NOTICE OF ALLOWANCE MAILED		Assistant Examiner	CLAIMS ALLOWED	
			Total Claims	Print Claim for O.G.
ISSUE FEE		Primary Examiner	DRAWING	
Amount Due	Date Paid		Sheets Drwg.	Figs. Drwg.
<input checked="" type="checkbox"/> TERMINAL DISCLAIMER		PREPARED FOR ISSUE	Application Examiner	
		WARNING: The information disclosed herein may be restricted. Unauthorized disclosure may be prohibited by the United States Code Title 35, Sections 122, 181 and 368, Possession outside the U.S. Patent & Trademark Office is restricted to authorized employees and contractors only.		

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